

**Search Notes**

Application/Control No.

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Examiner

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Applicant(s)/Patent under  
Reexamination

KIM, HWEE CHUL

Art Unit

2839

**SEARCHED**

Class	Subclass	Date	Examiner
361	690	1/26/2007	MCZ
	695		

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Inventor double patent search.	1/28/2007	MCZ
PLUS search.	1/22/2007	MCZ